

# InGaAsP/InP gain-levered tunable lasers

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## Abstract

A tunable gain-levered laser is fabricated on an InGaAsP ridge waveguide, and demonstrates increased CW differential efficiency and sharp DC turn-on, with hysteretic characteristics. The devices can be directly modulated up to  $> 2.5$  Gb/s.

## I. Introduction

Bistable laser diodes have been proposed for use in optical networks due to their enhanced differential quantum efficiency (DQE), signal regeneration properties, and even implementation of all-optical flip-flops[1]. Gain-levered lasers have demonstrated improved noise figure (NF) in passive microwave fiber-optic links[2]. Fabry-Perot ridge lasers with saturable absorber sections are one additional implementation and have demonstrated sharp DC turn-on characteristics[3].

In this work, we report on the implementation and performance of a gain-levered widely-tunable laser. The design utilizes a tunable sample-grating distributed Bragg reflector (SGDBR) laser [4] and splits the laser gain cavity into two electrically segmented sections. The gain-levered cavity yields high quantum efficiency and sharp turn-on. The SGDBR mirrors ultimately allow full C-band tunability from the vernier effect. The gain levered SGDBR may be particularly useful getting the most efficient modulation out of a limited photocurrent for optical wavelength converters[5].

## II. Gain levered SGDBR Laser Design

The device is illustrated schematically in Fig. 1(left) and consists of six sections with (from right-to-left) a SGDBR rear mirror, phase section, the QW cavity split into a  $460 \mu\text{m}$  long section (gain) and a  $90 \mu\text{m}$  long section (lever), a SGDBR front mirror and a  $550 \mu\text{m}$  long output SOA. The device is fabricated with a common  $1.4 Q$  InGaAsP waveguide, offset  $1.55 \mu\text{m}$  QW for the amplifier, gain and lever sections, and a single blanket InP ridge regrowth. Details of the fabrication process are given in [5]. The output SOA is provided to boost the laser output power. Typical operation conditions are  $I_{\text{gain}} = 50 \text{ mA}$ ,  $I_{\text{lever}} = 5 \text{ mA}$ ,  $I_{\text{SOA}} = 50 \text{ mA}$  for  $T_{\text{subs}} = 16^\circ\text{C}$ .

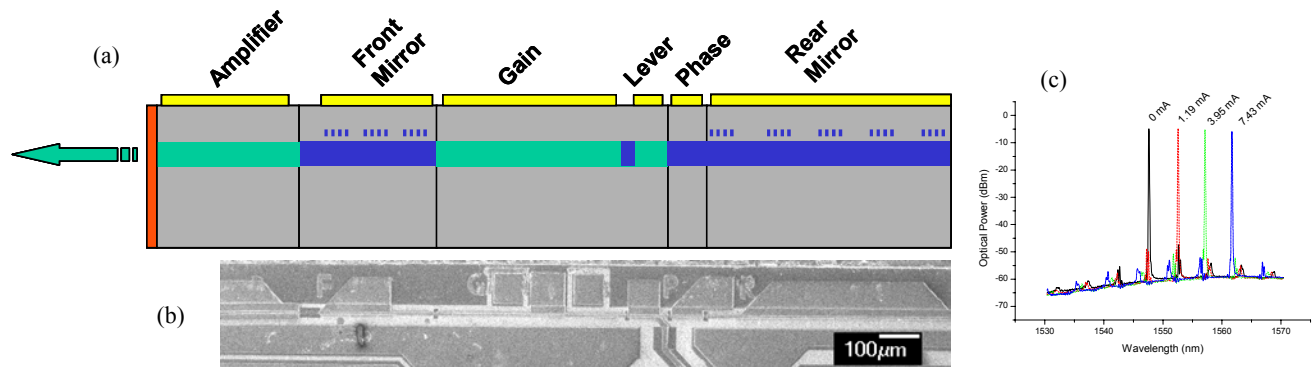


Figure 1. (a) Cross-section schematic of gain lever SGDBR (b) Top-down micrograph of fabricated device (c) optical spectra for as a function of rear mirror current.

### III. Device Results

The optical spectra for various rear mirror currents are superimposed in Figure 1(c) showing  $\sim 15\text{nm}$  of tuning with  $>35\text{dB}$  side mode suppression ratio. Continuous wave room temperature light-lever current measurements were taken as a function of gain section current (Figure 2a). With separately biased gain and lever contacts,  $I_{\text{th}}$  is reduced and slope efficiency at threshold is increased for increasing  $I_{\text{Gain}}$ . With shorted gain and lever contacts, threshold current ( $I_{\text{th}}$ ) was 30 mA. The L-I curve also shows hysteretic effects (Figure 2b). Small signal modulation response was measured on un-terminated devices (Figure 3a). Although we see hysteretic behavior in the L-I curve, the modulation bandwidth is at least as good as a conventional laser produced by shorting the contacts, 5.0 GHz for  $I_{\text{gain}} = 60\text{mA}$  and  $I_{\text{lever}} = 8\text{mA}$ . The devices were digitally modulated at 2.5 and 5 Gb/s and demonstrated open eyes as shown in Figure 3b and c.

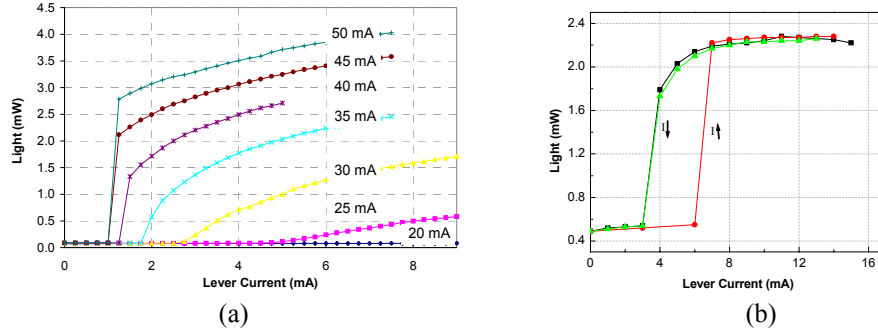


Figure 2. (a) CW L-I data for gain-levered SGDBR with  $I_{\text{gain}}$  as a parameter (1548nm emission, 30 mA  $I_{\text{SOA}}$ ) (b) hysteresis L-I curve showing dependence of L-I on increasing vs. decreasing lever current (1548nm emission, 70 mA  $I_{\text{SOA}}$ ).

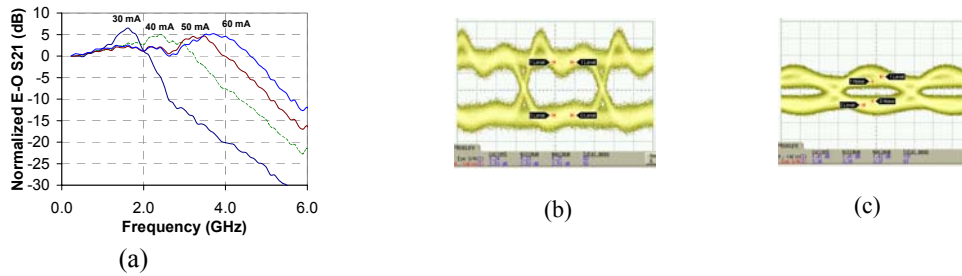


Figure 3. (a) Small signal gain lever laser bandwidth with  $I_{\text{GAIN}}$  as a parameter ( $I_{\text{SOA}} = 30\text{mA}$ ,  $I_{\text{LEVER}} = 8\text{mA}$ ) (b) 2.5 Gb/s NRZ eyes ( $2^{31}-1$  PRBS,  $I_{\text{SOA}} = 30\text{mA}$ ,  $I_{\text{GAIN}} = 60\text{mA}$ ,  $I_{\text{LEVER}} = 11\text{mA}$ ,  $V_{\text{RF}} = 1\text{V}$ ) (c) 5 Gb/s NRZ eyes ( $2^{31}-1$  PRBS) (same conditions as b)

### IV. Conclusions

We have presented our design and the performance of a tunable gain-levered ridge laser. The gain-levered SGDBR tunable laser is fabricated on a robust InGaAsP waveguide, InP ridge process suitable for standard ridge lasers, and demonstrates increased differential efficiency and sharp DC turn-on characteristics. Small-signal RF bandwidth of 5 GHz and clearly open eyes at 2.5 Gb/s were demonstrated.

This work was supported by DARPA/MTO CS-WDM under grant No. N66001-02-C-8026 and by Intel Corporation under grant No. TXA001630000.

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